

Initial Product/Process Change Notification Document #: IPCN22757X

Issue Date: 20 June 2019

Title of Change:		Addition of wafer fabrication site to United Microelectronics Corp, USA for wafer fab.						
Proposed First Ship date:		17 February 2020						
Contact Informa	tion:	Contact your local ON Somiconductor Sales Office or «Oceniu Alcali@ansomi com»						
Contact Informa	tion:	Contact your local ON Semiconductor Sales Office or < Osamu.Akaki@onsemi.com >						
Samples:		Contact your local ON Semiconductor Sales Office or < <u>PCN.Samples@onsemi.com</u> > Sample requests are to be submitted no later than 30 days from the date of first notification, Initial PCN or Final PCN, for this change. Samples delivery timing will be subject to request date, sample quantity and special customer packing/label requirements.						
Type of Notificat	This is an Initial Product/Process Change Notification (IPCN) sent to customers. An IPCN is an ad notification about an upcoming change and contains general information regarding the change detail devices affected. It also contains the preliminary reliability qualification plan. The completed qualification and characterization data will be included in the Final Product/Process C Notification (FPCN). This IPCN notification will be followed by a Final Product/Process Change Notification (FPCN) at least 90 days prior to implementation of the change. In case of questions, or < PCN.Support@onsemi.com					change details and ct/Process Change hange Notification		
Change Part Ide	Change Part Identification: It can be identified by lot number.							
Change Category:		✓ Wafer Fab Change						
Change Sub-Cate	egory(s):							
✓ Manufacturing Site Addition		Material Change		☐ Datasheet/Product Doc change				
☐ Manufacturing Site Transfer		Product specific change		Shipping/Packaging/Marking				
	ng Process Chang			Other:				
Sites Affected:		ON Semiconductor Sites: ON Aizu, Japan		External Foundry/Subcon Sites: Foundry: United Microelectronics Corp, USA				
Description and Purpose:								
This initial Product/Process Change Notification (IPCN) announces the fab transfer of UMC for wafer process.								
Niigata for Back grind (BG) and Back metal (BM) process and ONSC for assembly process are not changed.								
		Before Change		After Change]		
Process Description		Descrip	Description					
	Wafer fab	ON Aizu, Japan	ON A	izu, Japan	United			
	ИВМ	JX Nippon Mining & Metals Corporation, Japan	Metals	on Mining & Corporation, Japan	Microelectronics Corp, USA			
There is no product marking change as a result of this change.								

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Qualification Plan:

QV DEVICE NAME: EFC2K103NUZTDG

RMS: S50064 PACKAGE: WLCSP

Test	Specification	Condition	Interval
HTRB	JESD22-A108	Ta=150°C, 80% max rated V	1,008 hrs
HTGB	JESD22-A108	Ta=150°C, 100% max rated Vgss	1,008 hrs
HTSL	JESD22-A103	Ta= 150°C	1,008 hrs
IOL	MIL-STD-750 (M1037) AEC-Q101	Ta=+25°C, delta Tj=100°C On/off = 2 min	15,000 cyc
TC	JESD22-A104	Ta= -40°C to +125°C	1,000 cyc
HAST	JESD22-A110	130°C, 85% RH, 18.8psig, bias	96 hrs
UHAST	JESD22-A118	130°C, 85% RH, 18.8psig, unbiased	96 hrs
LTSL	JESD22-A119	Ta=-55°C	1,008hrs

List of Affected Parts:

Note: Only the standard (off the shelf) part numbers are listed in the parts list. Any custom parts affected by this PCN are shown in the customer specific PCN addendum in the PCN email notification, or on the **PCN Customized Portal**.

Part Number	Qualification Vehicle		
EFC2K103NUZTDG	EFC2K103NUZTDG		
EFC2K102NUZTDG	EFC2K103NUZTDG		

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